PO TO PAGE (modified)			ATTY DOCKET NO. 862.C2072	APPLICA	09/733,980	
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115	5,834,783	11/98	MURAKI ET AL.	250	398	
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11/18	M. Parikhh, J., Corrections To Proximity Effects in Electron Beam Lithography, App. Phys. 50(g), pp. 4378-4382 (1979)					
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy o this form with next communication to applicant.

Sheet\_1\_ of \_1\_